

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
1	BRS	L1	13	thin adj film with nanowire with deposit\$4 and source with drain and nanowire with channel	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/26 17:52			
2	BRS	L2	21	nanowire near (deposit\$4 or flow\$ or plac\$4) and source with drain and nanowire with channel	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/26 18:01			
3	BRS	L3	14	semiconduct\$4 with nanowire with (deposit\$4 or flow\$) and source with drain and nanowire with channel	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/26 18:13			
4	BRS	L4	80	semiconduct\$4 with nanowire with (deposit\$4 or flow\$)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/26 18:29			

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
5	BRS	L5	7	(semiconduct\$4 with nanowire with (deposit\$4 or flow\$)).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2005/11/26 18:29			